

## APPLICATION DATA SHEET

### APPLICATION INFORMATION

Application Type:: REGULAR  
Subject Matter:: UTILITY  
CD-ROM or CD-R?: NONE  
Title:: SUBSTRATE PROCESSING METHOD  
AND SUBSTRATE PROCESSING  
APPARATUS  
Attorney Docket Number:: 216944US-3 DIV  
Total Drawing Sheets:: 17

### INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR  
Primary Citizenship Country:: JAPAN  
Status:: FULL CAPACITY  
Given Name:: SHINJI  
Family Name:: NAGASHIMA  
City of Residence:: KIKUCHI-GUN  
Country of Residence:: JAPAN  
Street of Mailing Address:: C/O INTELLECTUAL PROPERTY DEPT.  
TOKYO ELECTROL LIMITED  
3-6 AKASAKA 5-CHOME  
City of Mailing Address:: MINATO-KU, TOKYO  
Country of Mailing Address:: JAPAN  
Postal or Zip Code of Mailing Address:: 8481

### CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

### REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

### DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Division of	09/611,664	07/06/00

### FOREIGN PRIORITY INFORMATION

Application Number::	Country::	Filing Date::	Priority Claimed::
11-193671	Japan	07/07/99	YES

Project "Echelon"